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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of: Chung-Hui Chen et al.

Confirmation No.: 1488

Serial No.: 10/784,705

Group Art Unit: 2811

Filed: February 23, 2004

Examiner: Not Yet Assigned

For: **PROGRAMMABLE MOS DEVICE FORMED BY STRESSING
POLYCRYSTALLINE SILICON**

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Steven E. Koffs

Steven E. Koffs, Registration No. 37,163

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CHANGE OF CORRESPONDENCE ADDRESS

Please change the correspondence address for the above-identified patent
application to:

Customer No: 08933

Steven E. Koffs, Esq.

Duane Morris LLP

One Liberty Place

Philadelphia, Pennsylvania 19103-7396

Tel: 215-979-1250

Fax: 215-979-1020

Respectfully submitted,

Dated:

3-30-05

Steven E. Koffs

Steven E. Koffs, Esquire
Registration No. 37,163
Attorney for Applicant(s)

DUANE MORRIS LLP
One Liberty Place
Philadelphia, PA 19103
215-979-1050 tel
215-979-1020 fax